

Fig. 1

2/20

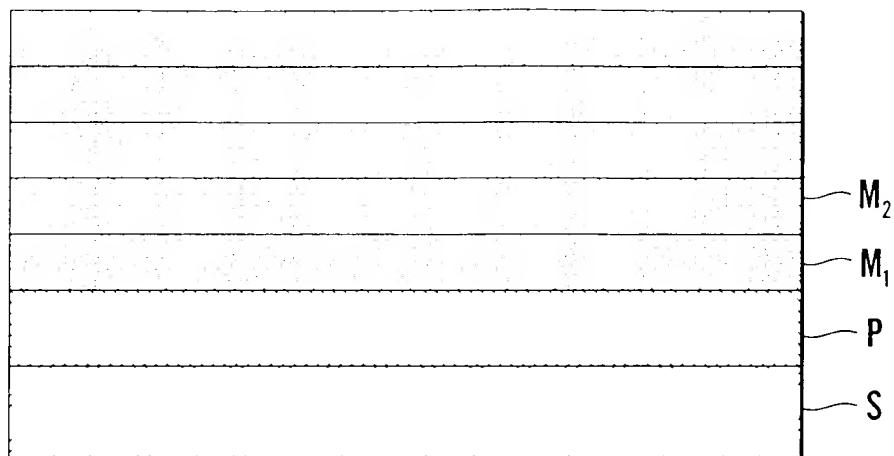


Fig.2

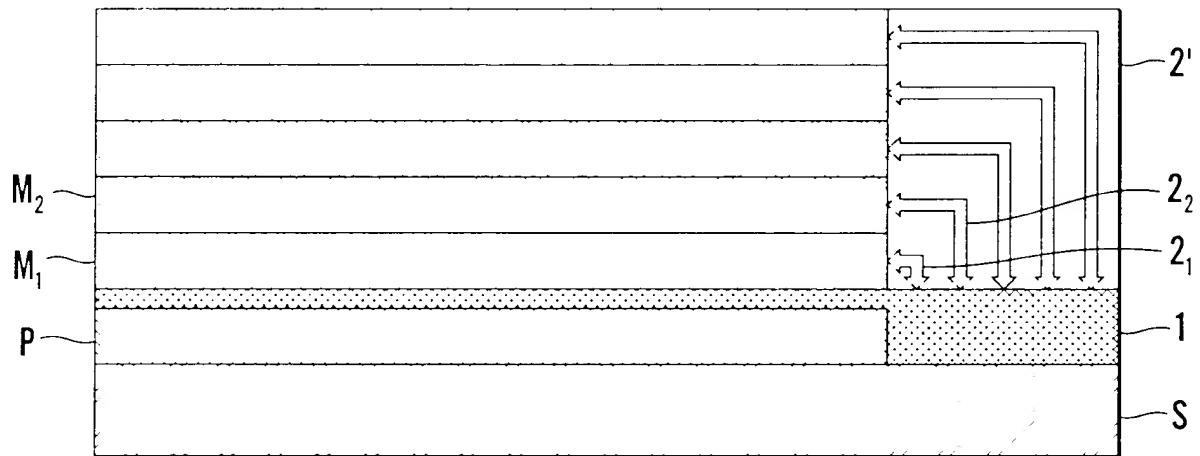


Fig.3

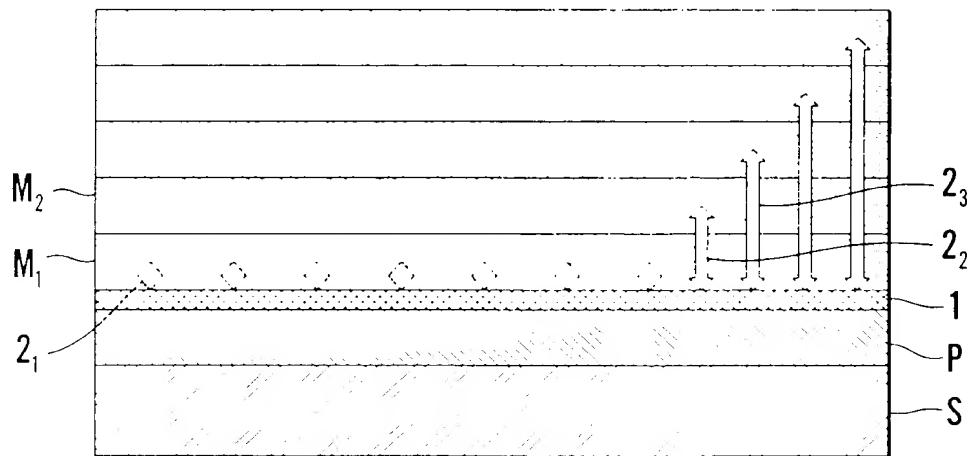


Fig.4

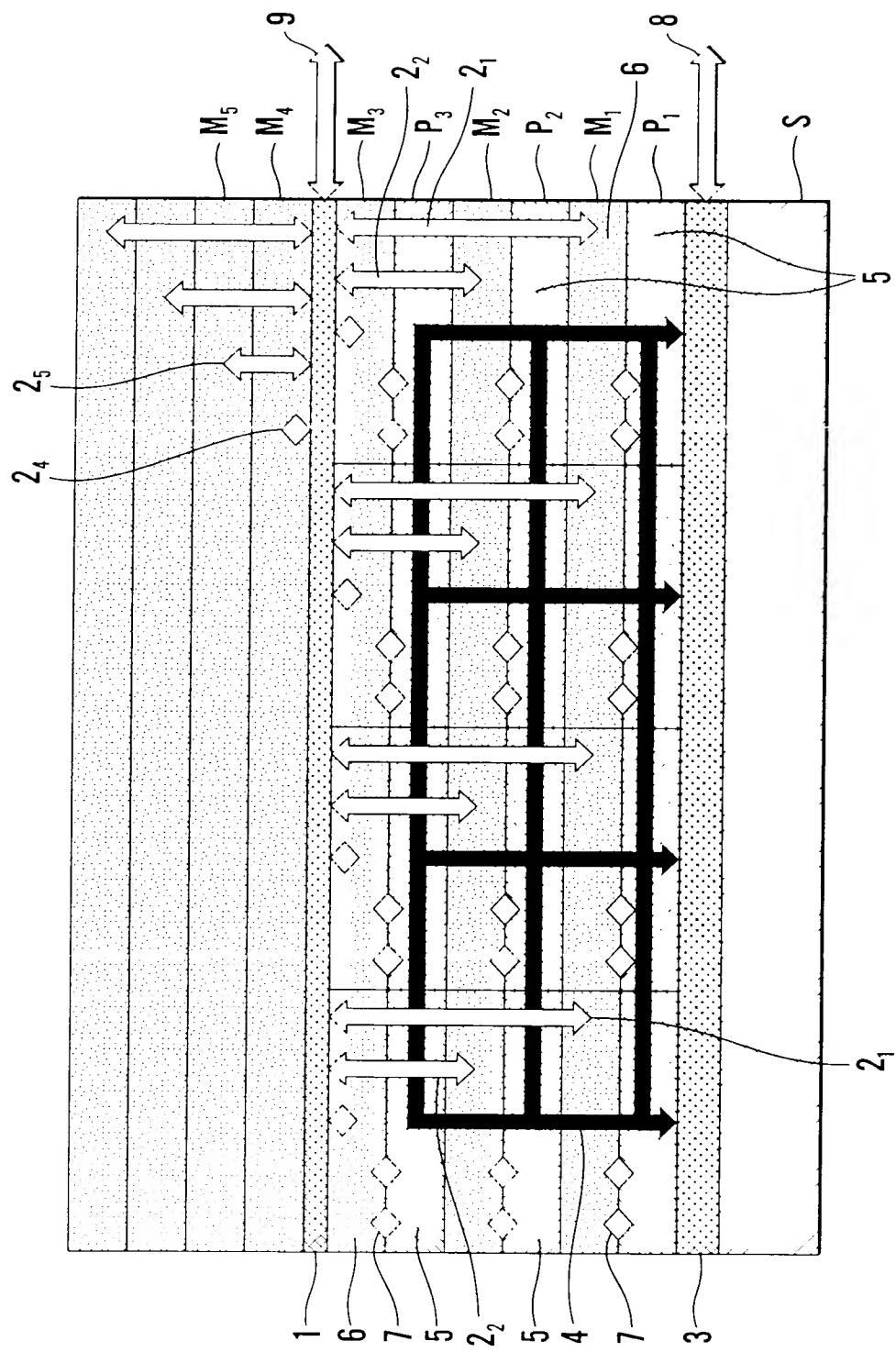


Fig. 5

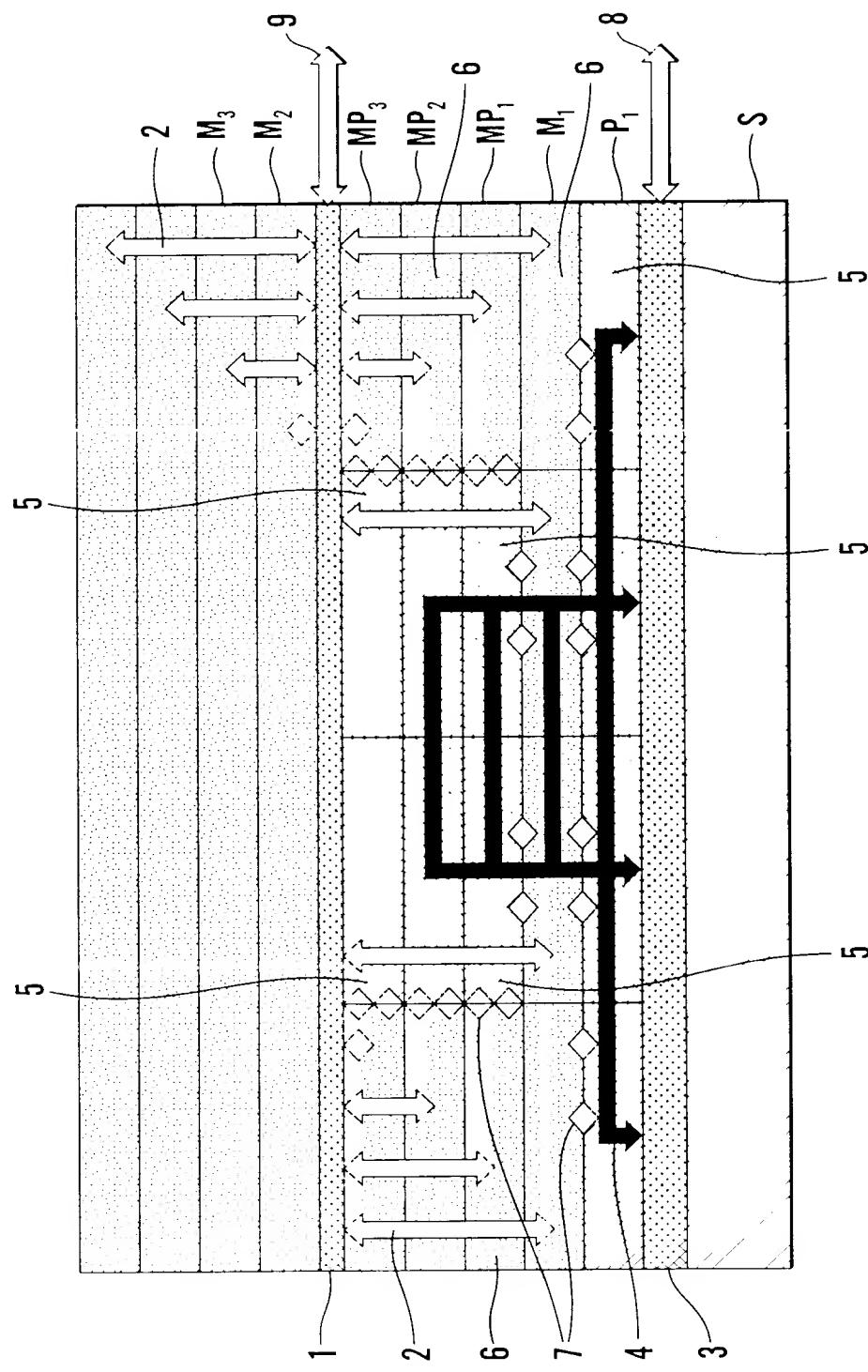


Fig. 6

5/20

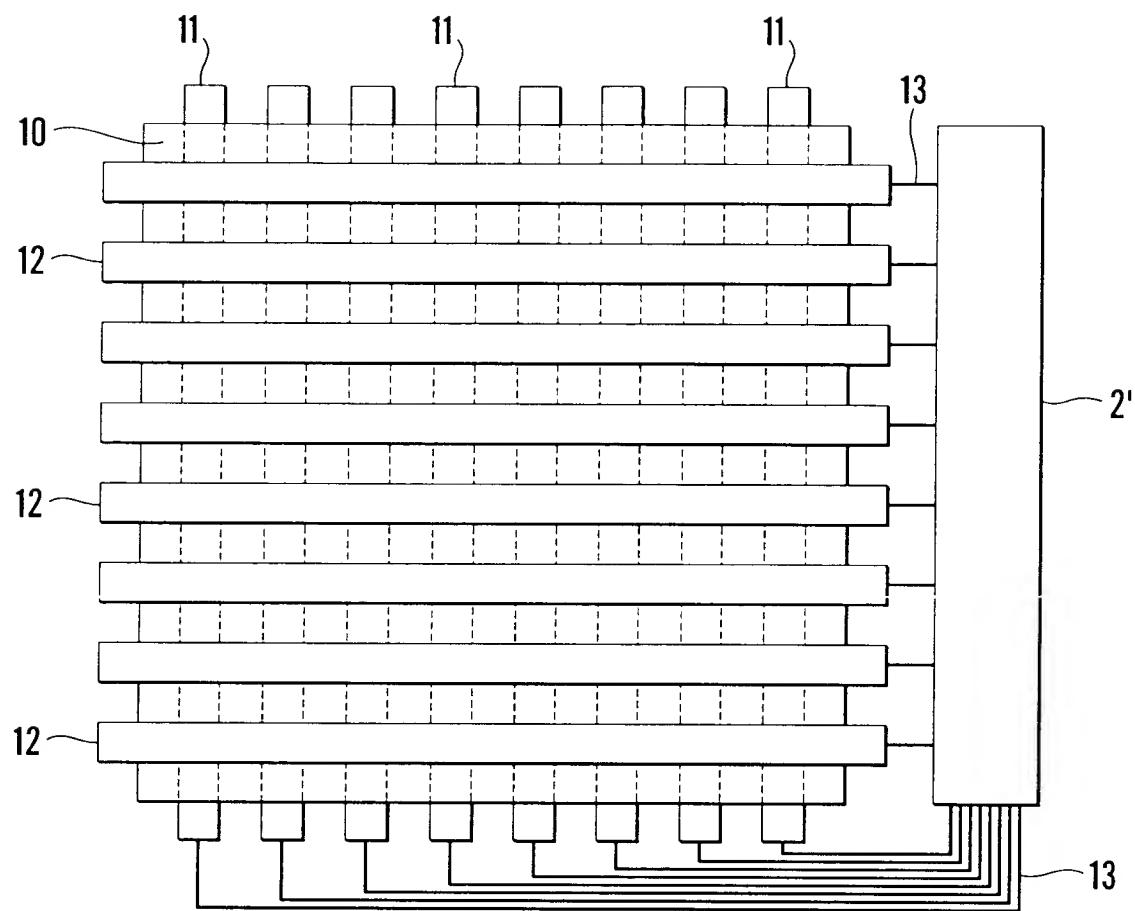


Fig. 7a

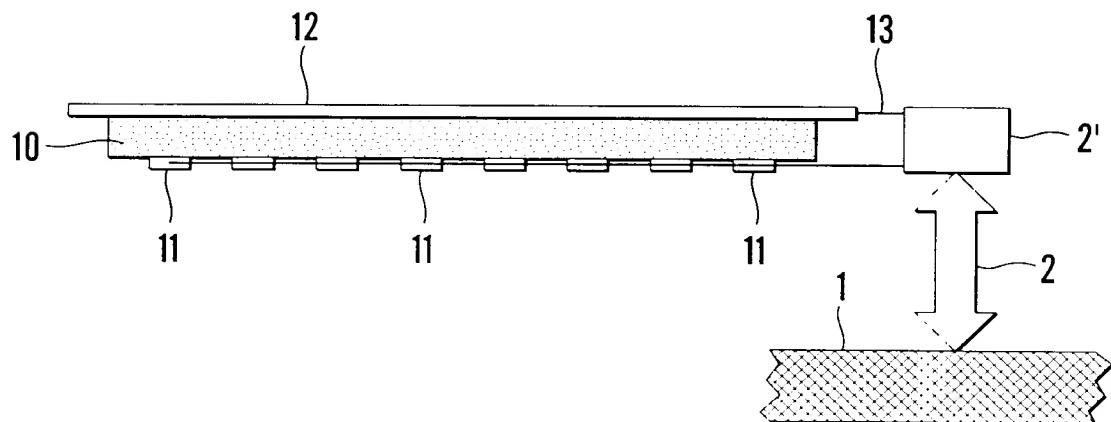


Fig. 7b

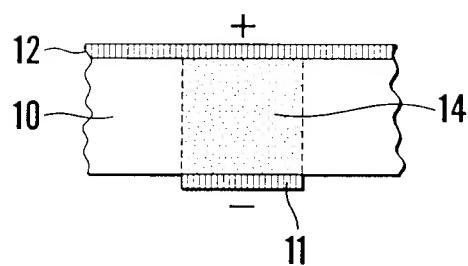


Fig. 7c

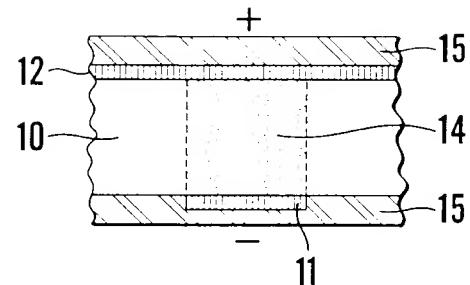


Fig. 7d

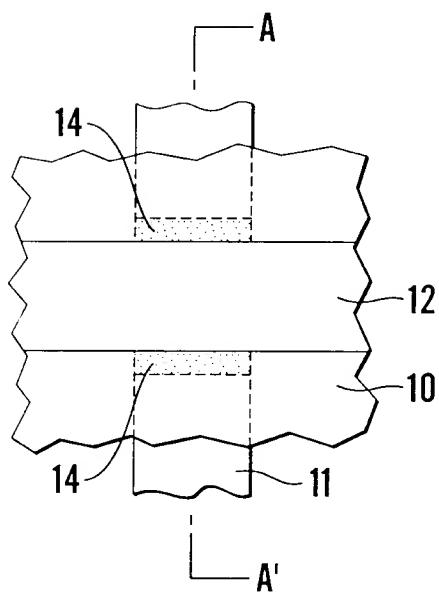


Fig. 7e

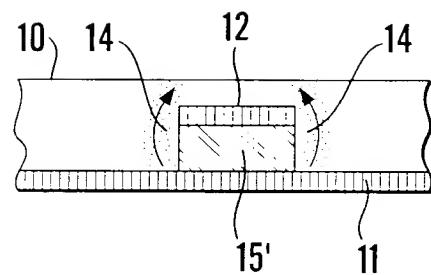


Fig. 7f

7/20

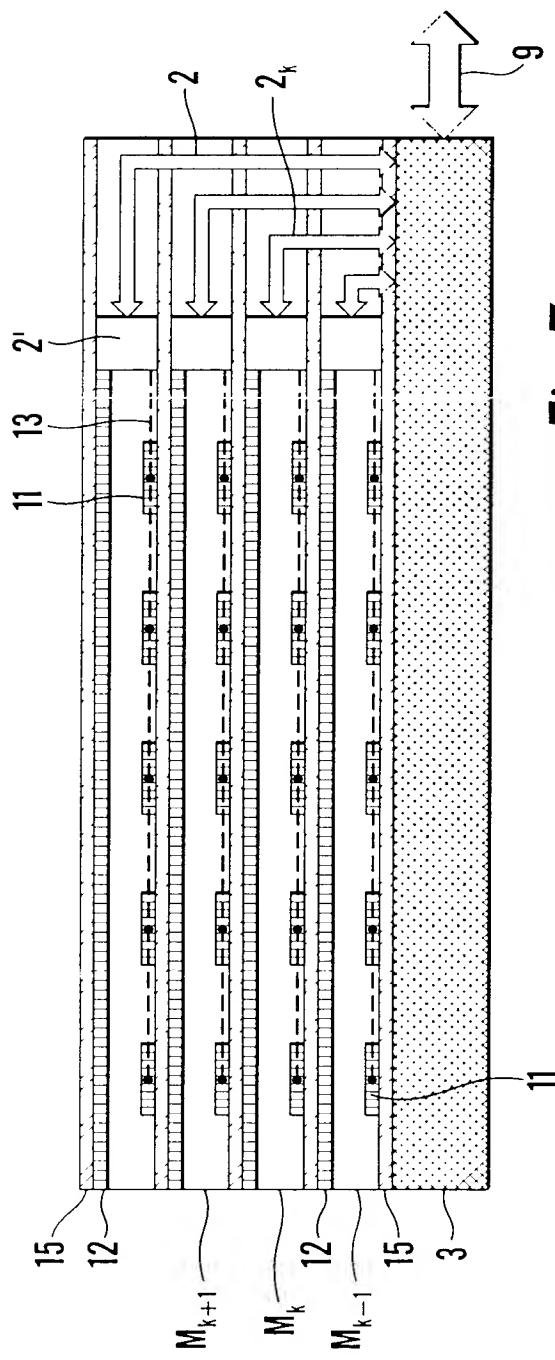


Fig. 7g

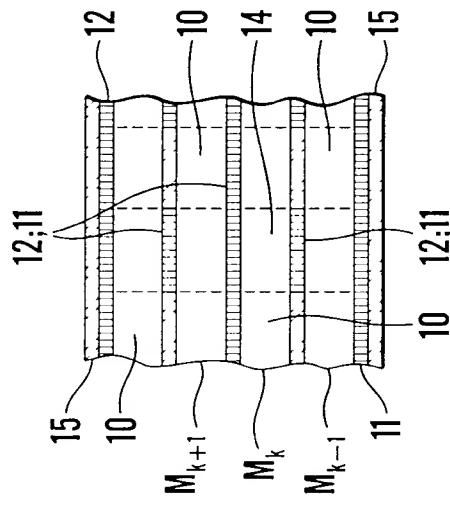


Fig. 7h

8/20

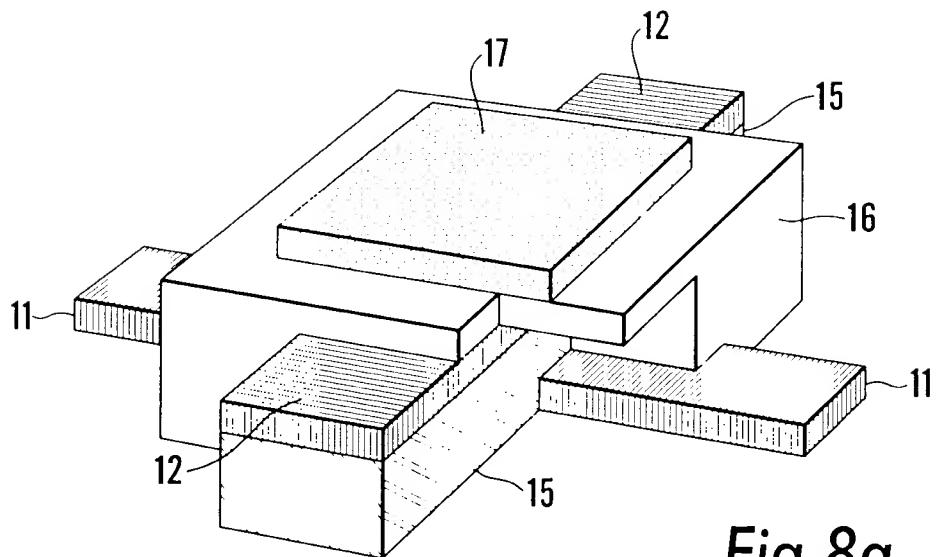


Fig. 8a

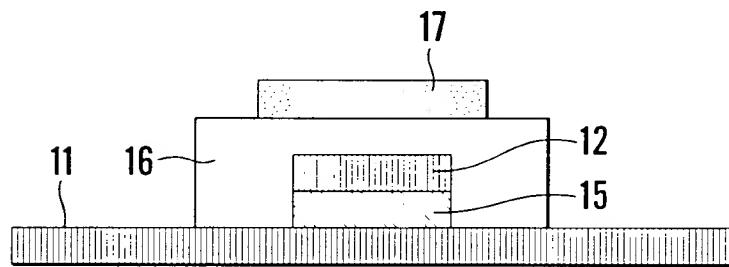


Fig. 8b

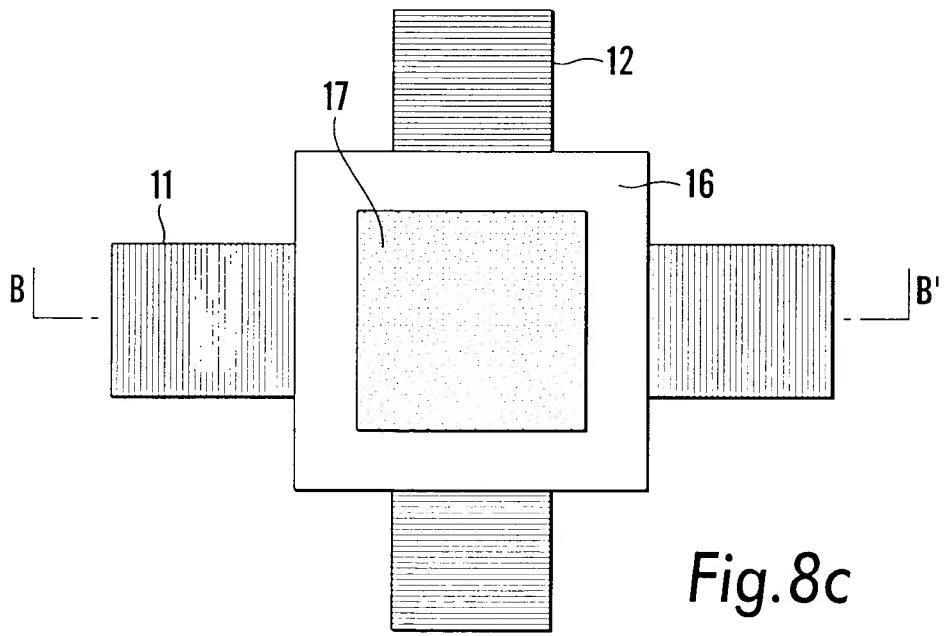


Fig. 8c

9/20

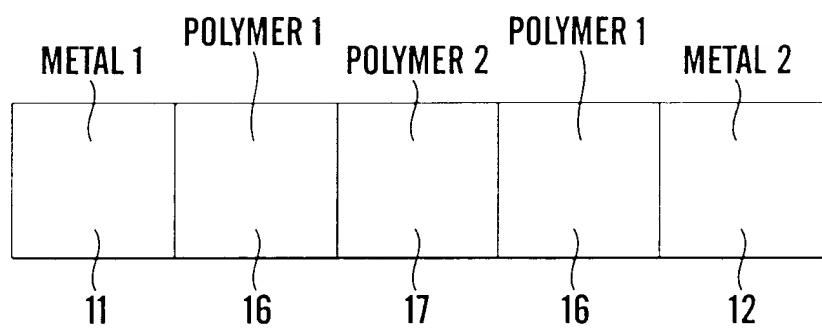


Fig.9

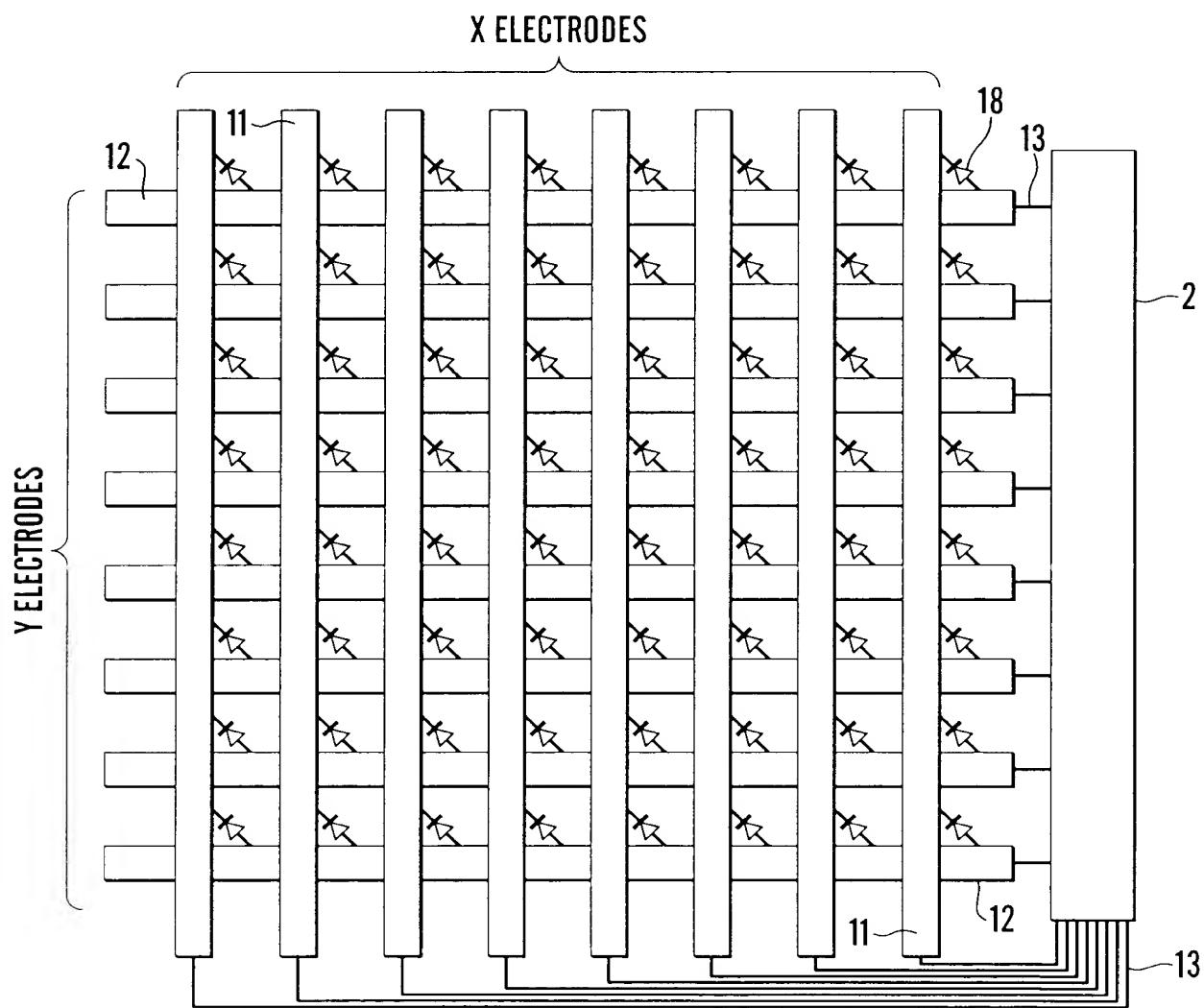


Fig.10

10/20

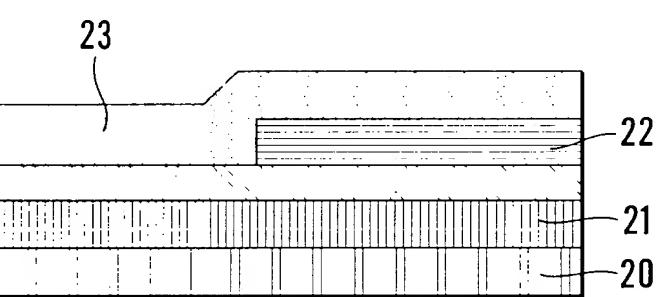
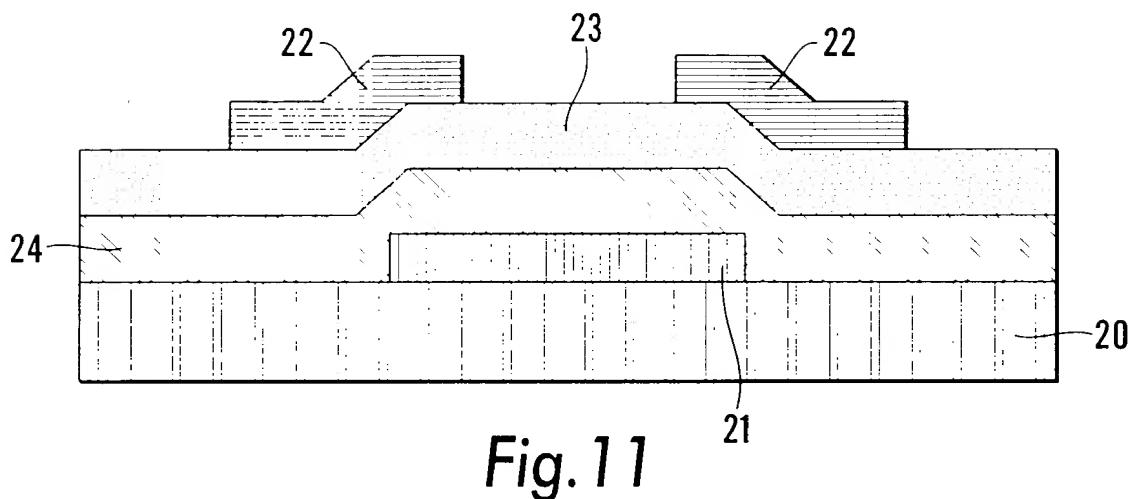


Fig. 12

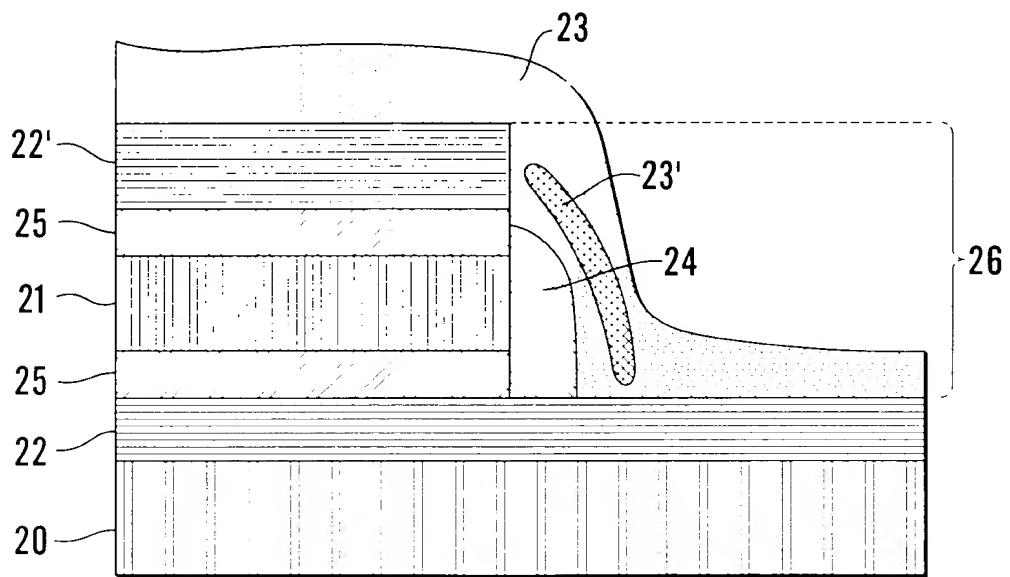


Fig. 13

11/20

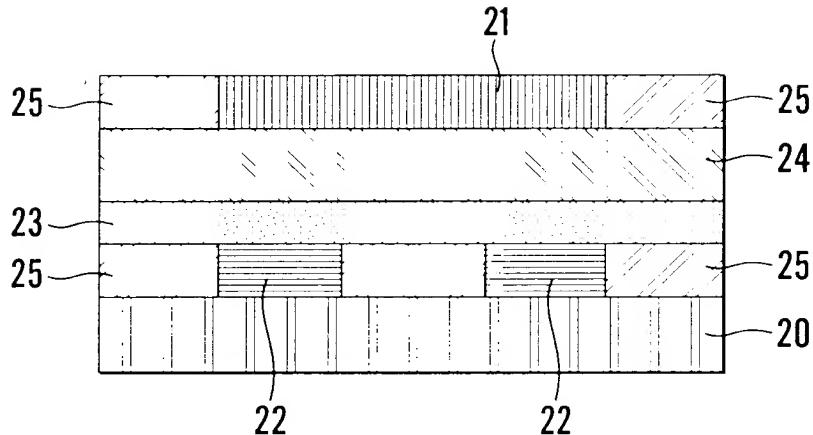


Fig. 14

LEGEND TO FIGS. 15-21

	ISOLATING
	SEMICONDUCTING
	p-TYPE SEMICONDUCTING
	n-TYPE SEMICONDUCTING
	CONDUCTING, ELECTRODES
	HORIZONTAL AND VERTICAL CONDUCTING PATH (△, UP; ▽, DOWN)

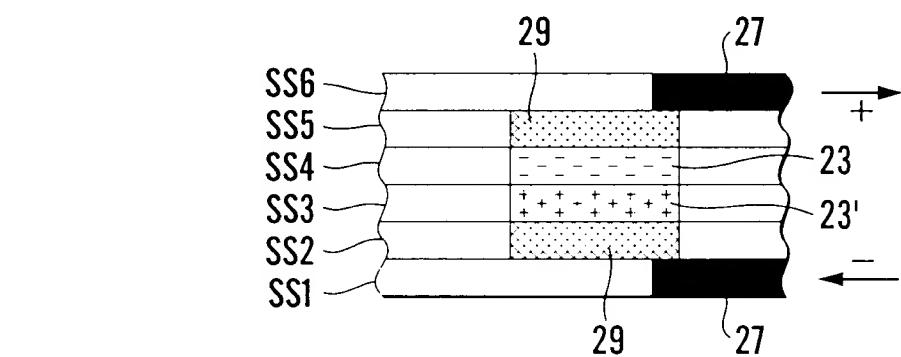
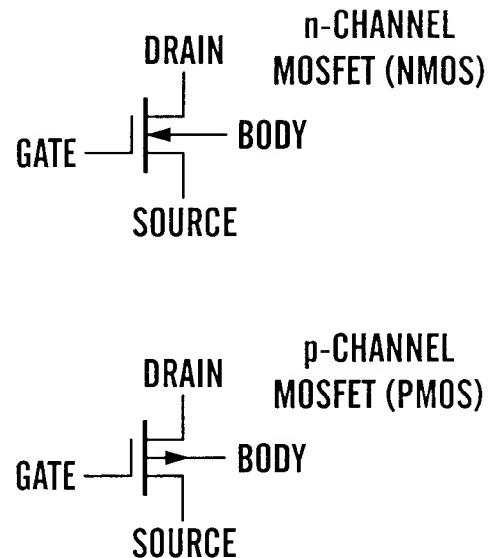


Fig. 15

12/20

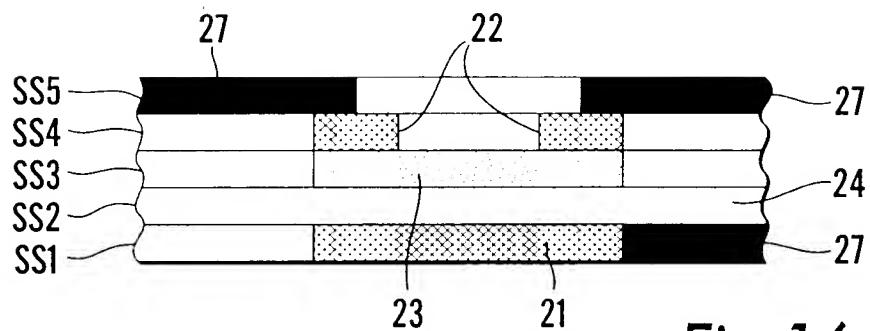


Fig. 16

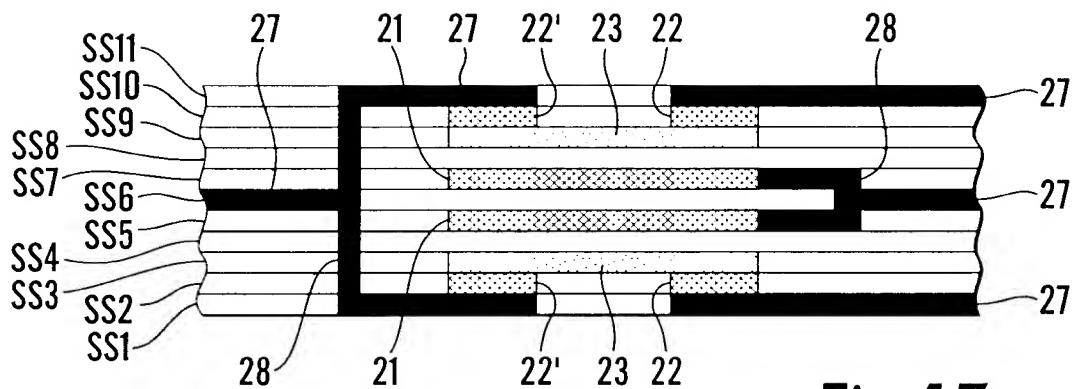


Fig. 17a

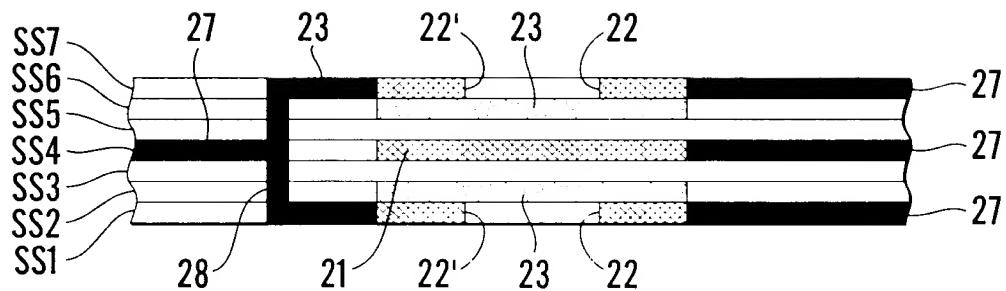


Fig. 17b

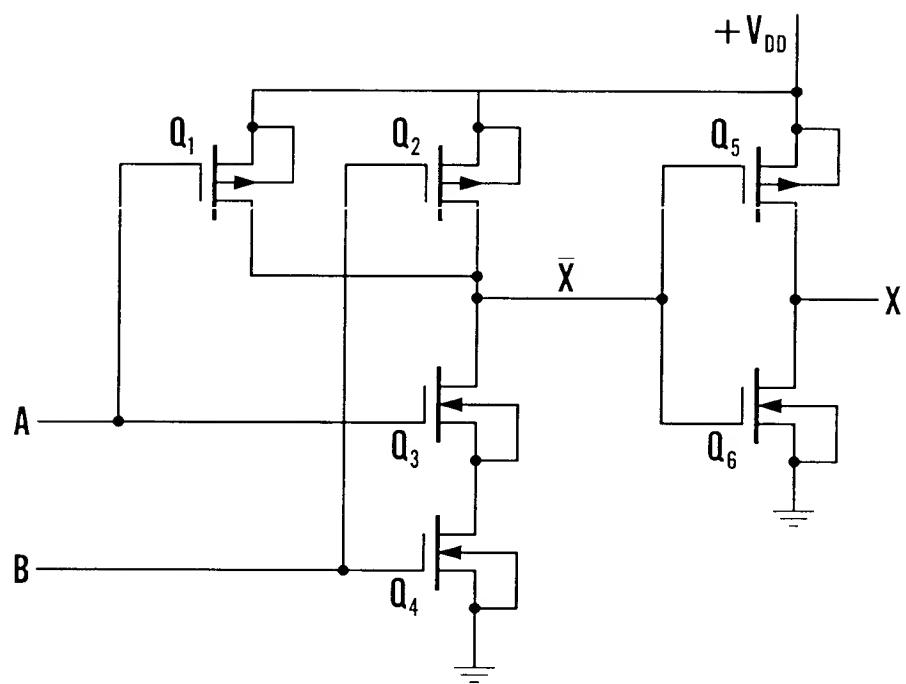


Fig. 18

14/20

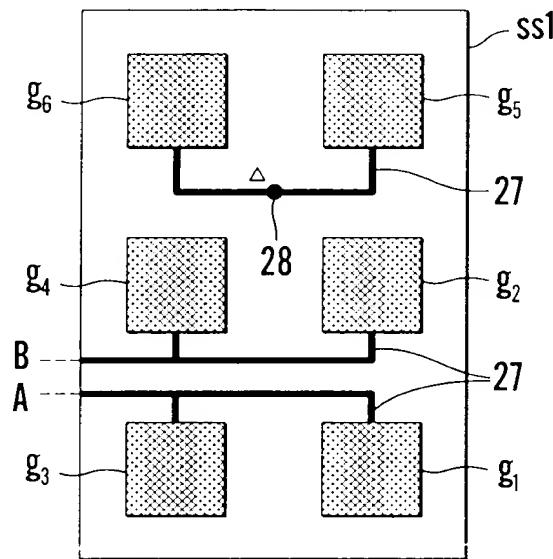


Fig. 19a

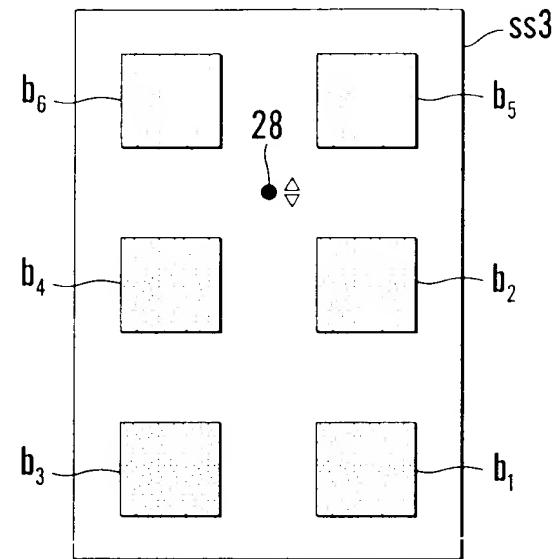


Fig. 19b

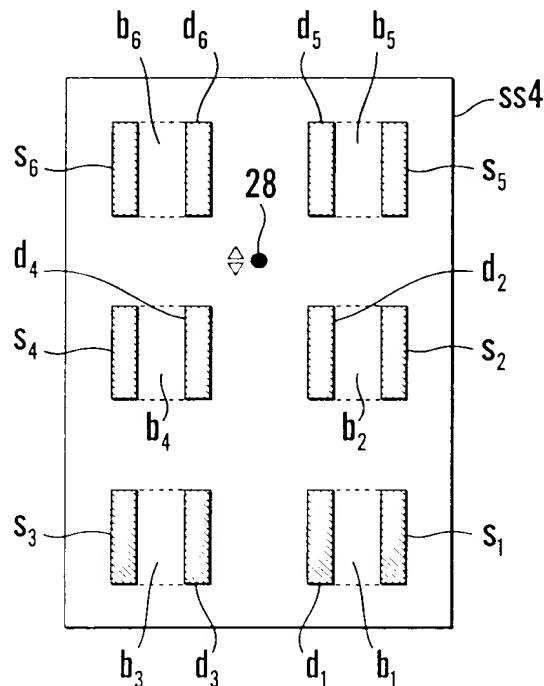


Fig. 19c

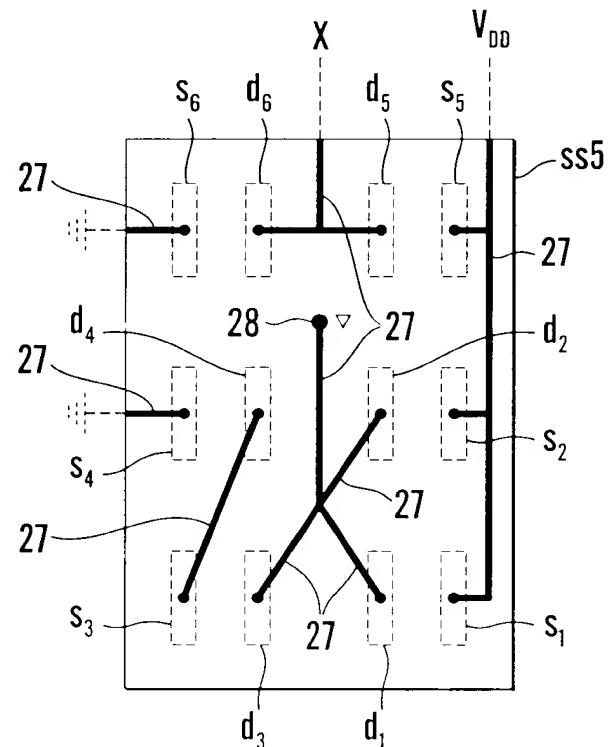


Fig. 19d

15/20

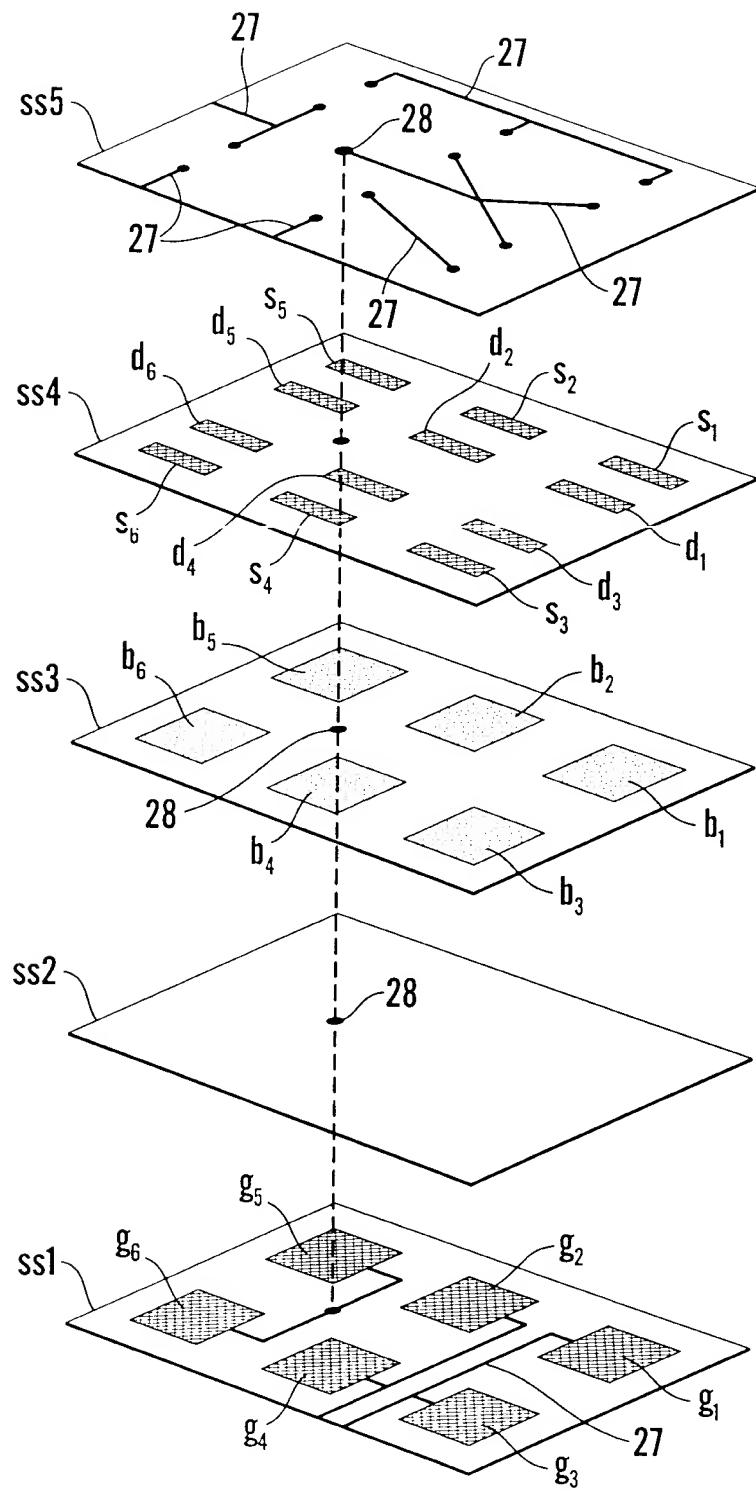


Fig.20

16/20

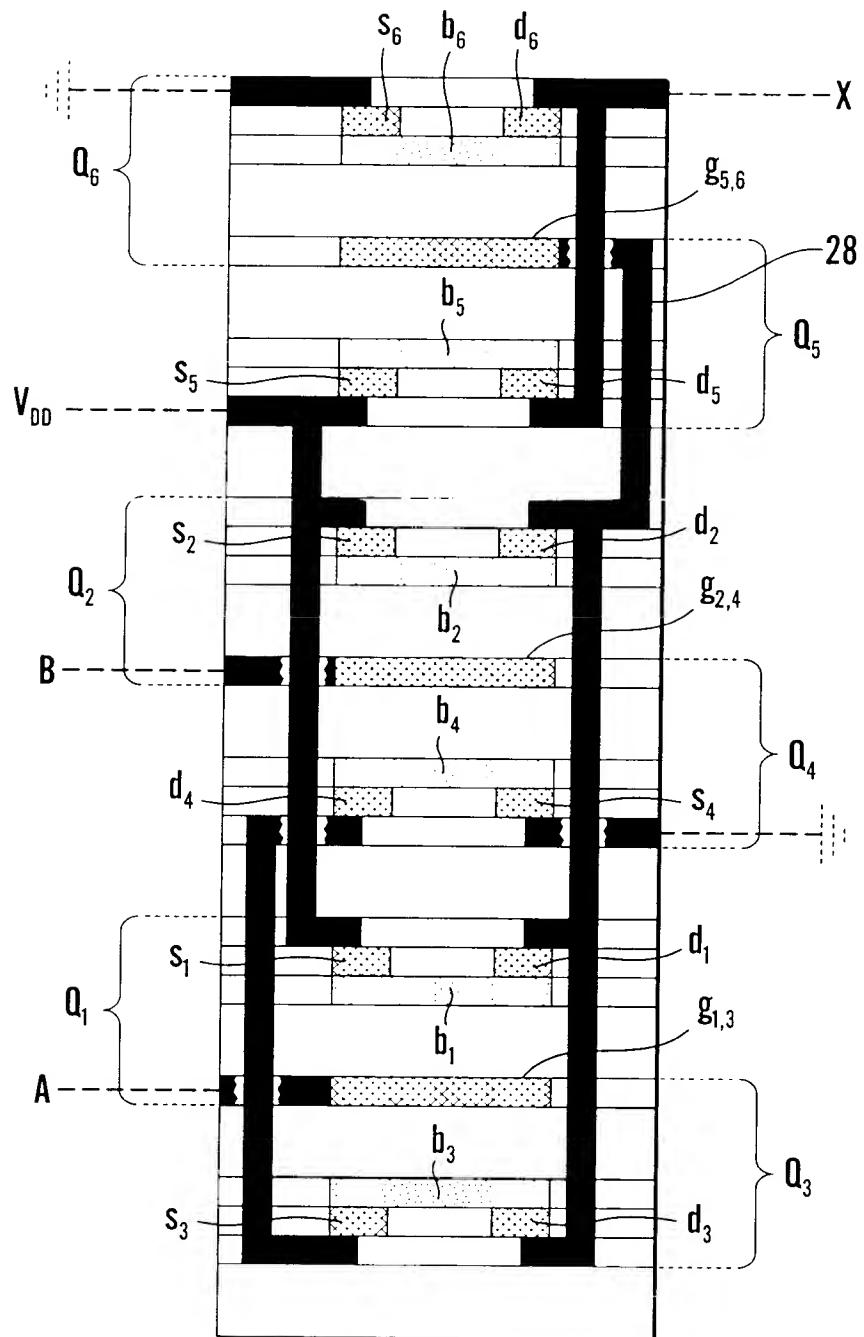


Fig.21a

17/20

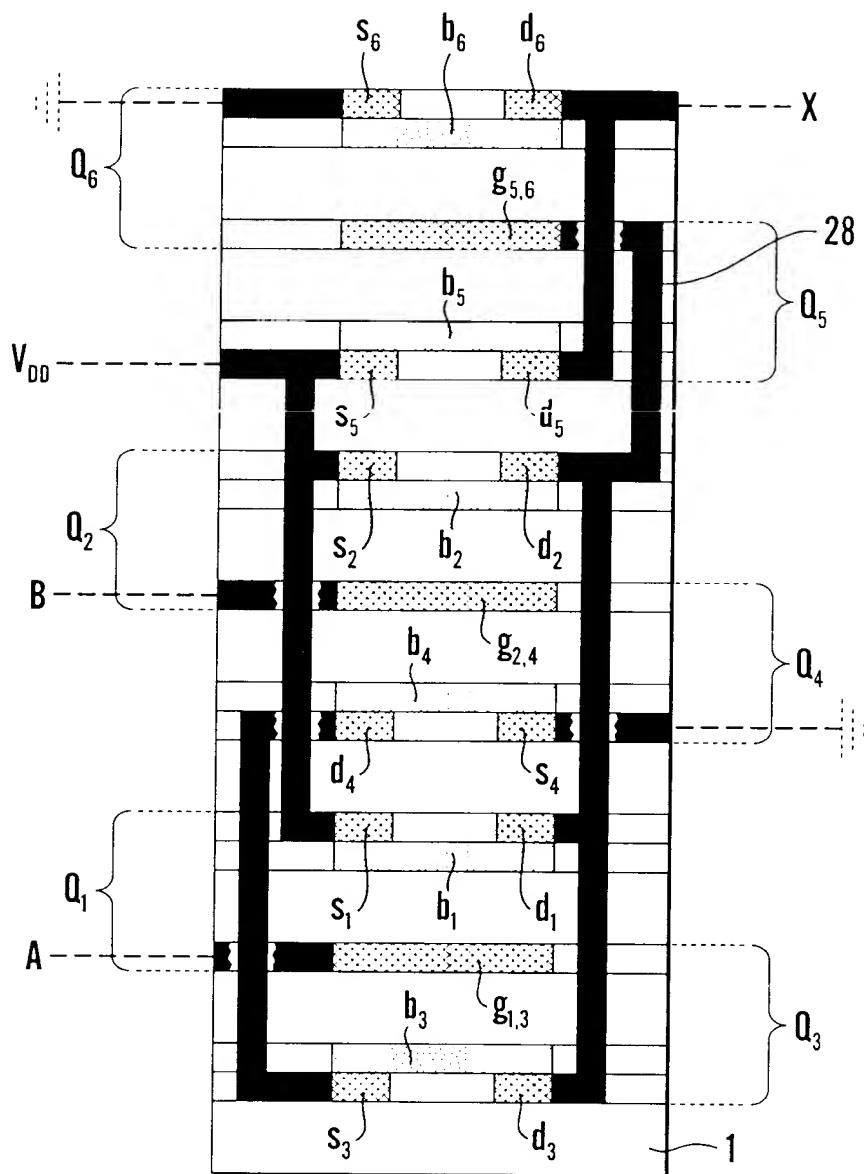


Fig.21b

18/20

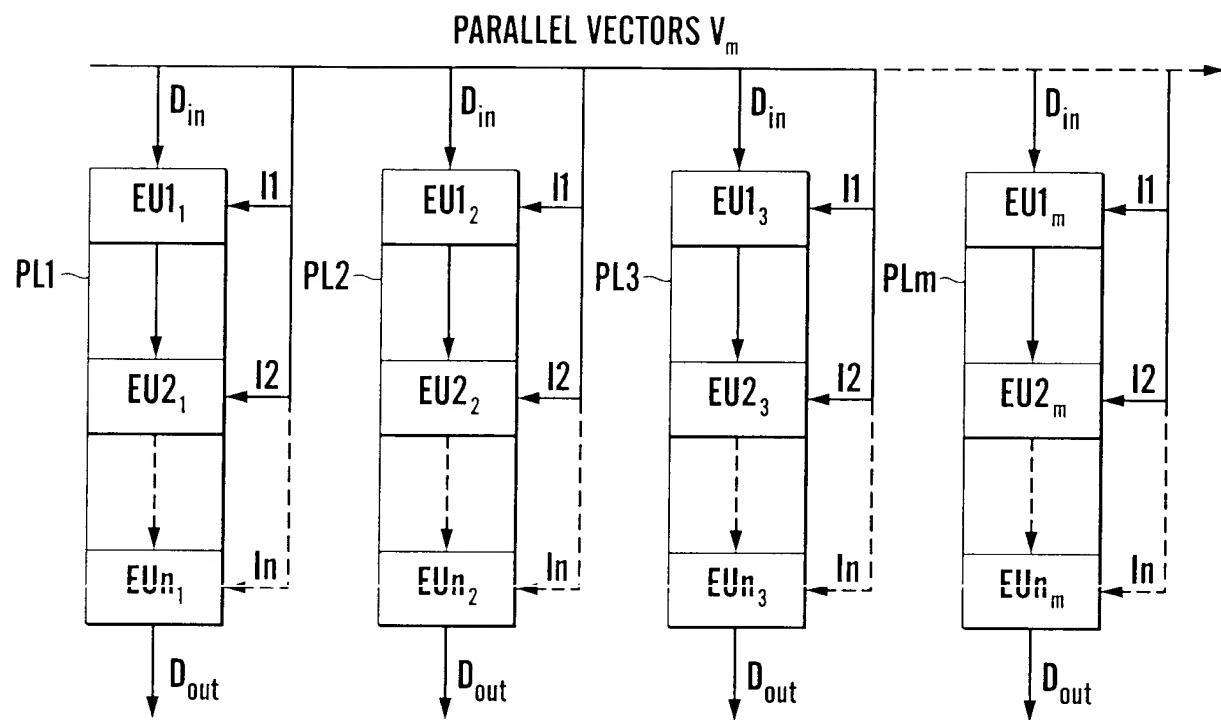


Fig.22

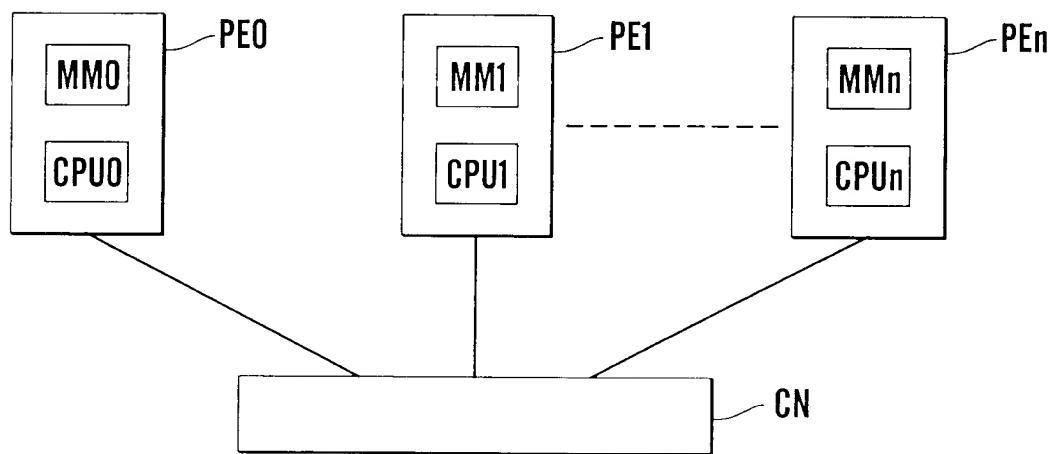


Fig.23

19/20

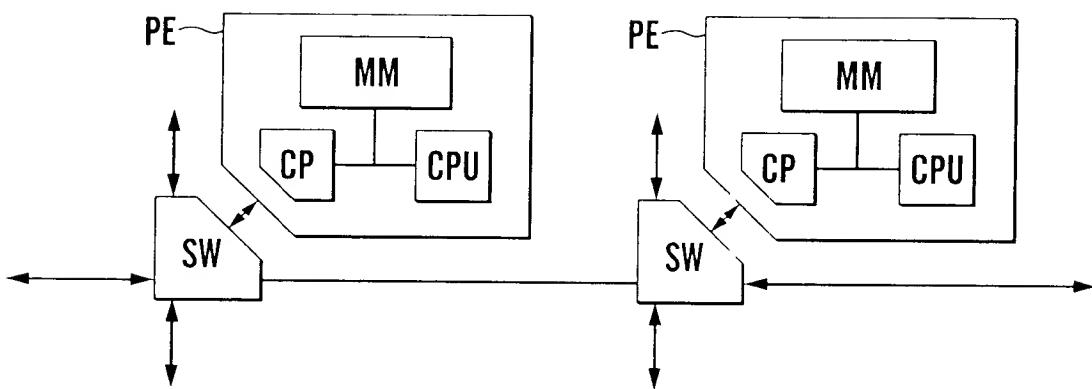


Fig.24

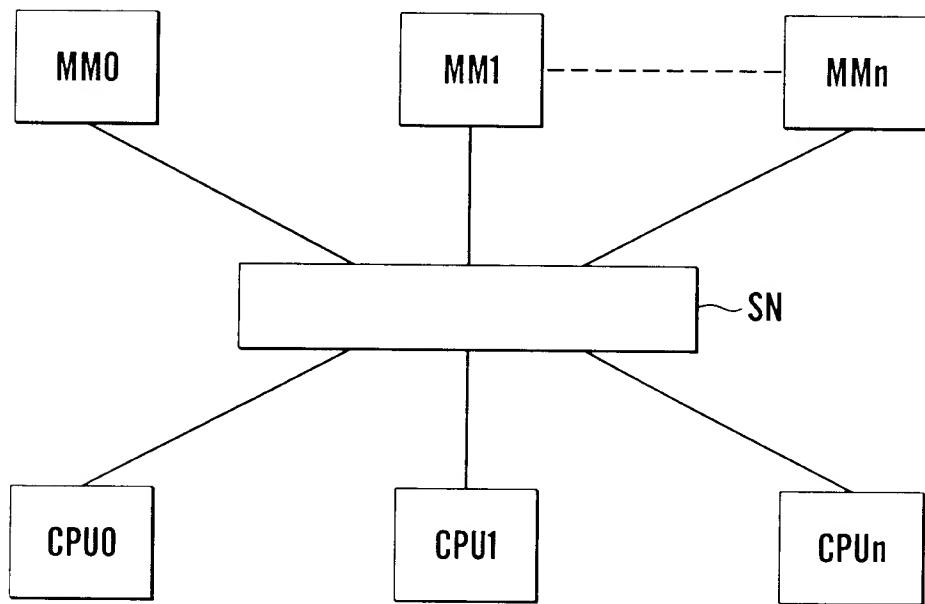


Fig.25

20/20

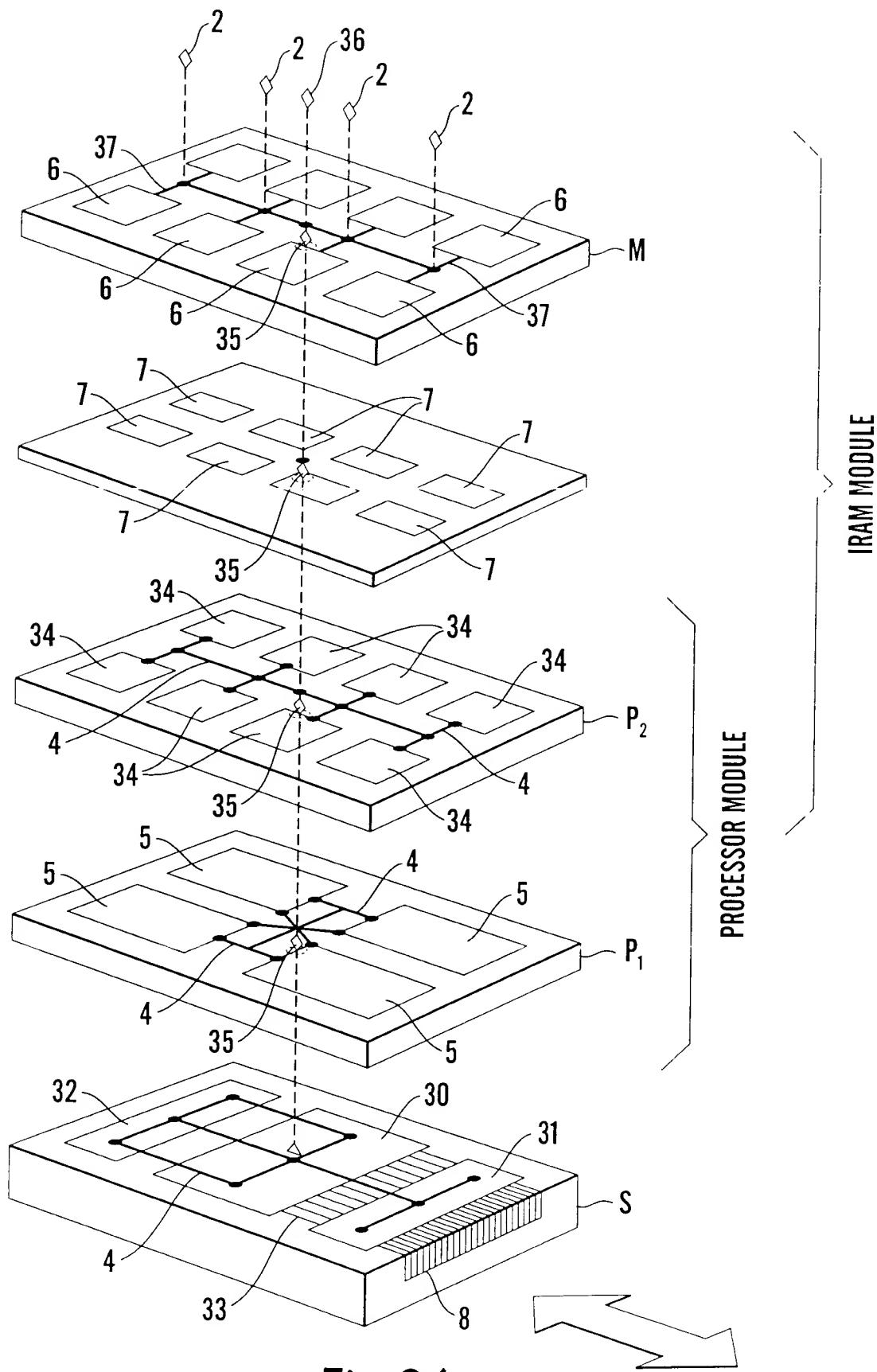


Fig. 26